

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application of :
Toshio KODAMA et al. :
Serial No. (not yet assigned) :
Filed: February 22, 2005 :
For: ION BEAM DEVICE AND ION :
BEAM PROCESSING METHOD : Docket No. S004-5460 (PCT)

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SECOND PRELIMINARY AMENDMENT

S I R:

Applicants preliminarily amend their application as
follows:

BY EXPRESS MAIL ON FEBRUARY 22, 2005 (EV 504 367 757 US)